THE 58TH WIPO ASSEMBLIES

CDIP STATEMENT BY KENYAN DELEGATION

Thank you Mr. Chairman;

The Kenyan delegation appreciates the good work that has been done by the CDIP committee under the able leadership of the chairman and his two deputies.

Mr. Chairman the Kenyan delegation has always believed it is important to align the WIPO development Agenda with the national Agenda. This delegation has taken note of the CDIP report contained in document WO/GA/50/7.

Kenya is in the process of enhancing its manufacturing capacity and this cannot be realised if the SMEs and Small Industries are not assisted to reached their maximum potential. Because of this, we believe WIPO has a role to play in assisting countries like Kenya in achieving its agenda.

We are looking for Technologies that are less costly and easily adaptable to our environment. It is still a challenge for acquisition of technology by SMEs. Lack of basic link between the SMEs and technology databases has been the main contributor to low rate of Technology Transfer. More effort should be put on promotion of WIPO activities and resources related to Technology transfer, especially for SMEs.

The Delegation notes with sincere appreciation WIPO’s continued support of the TISCs project for increased access to available scientific and technical information in developing countries. By improving access to scholarly literature from diverse fields of science and technology, the TISCs project has high potential in supporting researchers in developing countries towards creating and developing solutions to technical challenges faced by the resilient society in day to day life. The Government of Kenya has continued to encourage and promote the establishment of TISCs centers in institutions of learning including those for research and development. There is an increased number of institutions that are signing MOUs for establishing TISC centers.

We welcome more discussions on same during future CDIP meetings and hope it will be fast tracked in the coming year.

Thank you Mr. Chairman.